

THIRD WORKSHOP ON THIN FILM PHYSICS AND TECHNOLOGY,
including TOPICAL CONFERENCE ON MICROSTRUCTURE AND
SURFACE MORPHOLOGY EVOLUTION IN THIN FILMS (REPOSITORY
FOR LECTURE NOTES FROM THE SCANNED HISTORICAL ARCHIVE)
| (smr 1135)

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**H-MEDIATION, SURFACE SEGREGATION,
ULTRA-HIGH DOPING AND THEIR EFFECTS ON
 $\text{Si}_{1-x}\text{Ge}_x$ GROWTH KINETICS**

Content

Summary

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